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AMENDMENT TRANSMITTAL LETTER				Docket No. SON-1285/DIV	
Application No. 10/752,705-Conf. #5551	Filing Date January 8, 2004	Examiner Jack S. J. Chen	Art Unit 2813		
Applicant(s): Takashi Noguchi et al.					
Invention: FIELD EFFECT TRANSISITOR AND FABRICATION THEREOF, SEMICONDUCTOR DEVICE AND FABRICATION THEREOF, LOGIC CIRCUIT INCLUDING THE SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR SUBSTRATE					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	13	- 27 =		x	0.00
Independent Claims	3	- 7 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					<b>0.00</b>
<input checked="" type="checkbox"/> Large Entity <span style="margin-left: 200px;"><input type="checkbox"/> Small Entity</span>					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ 0.00 A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 18-0013 as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
Ronald P. Karanen Attorney Reg. No.: 24,104  RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750				Dated: November 13, 2006	



Docket No.: SON-1285/DIV  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:

Takashi Noguchi, et al

Conf. # 5551

Application No.: 10/752,705

Group Art Unit: 2813

Filed: January 8, 2004

Examiner: Jack S.J. Chen

For: FIELD EFFECT TRANSISTOR AND  
FABRICATION THEREOF,  
SEMICONDUCTOR DEVICE AND  
FABRICATION THEREOF...  
\_\_\_\_\_

**RESPONSE TO NON-FINAL ACTION OF AUGUST 11, 2006**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In full and timely response to the Office Action mailed on August 11, 2006, please further amend the above-identified application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 15 of this paper.